



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Fumio KOYAMA et al.

Group Art Unit: 2828

Application No.: 10/026,637

Examiner: A. Rodriguez

Filed: December 27, 2001

Docket No.: 111587

For: SURFACE EMITTING SEMICONDUCTOR LASER AND MANUFACTURING
METHOD THEREOF

AMENDMENT UNDER 37 C.F.R. §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the April 29, 2004 Office Action, the period for reply being extended by the attached Petition for Extension of Time, and further to the August 25, 2004 personal interview with Examiner Rodriguez, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.